PATENT S/N 09/825,613

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Sujit Sharan et al.

Examiner: Asok K Sarkar

Serial No.:

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METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS

AMENDMENT UNDER 37 CFR § 1.111

ail Stop Petition

Commissioner for Patents

P.O. Box 1450

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This paper responds to the Decision on Appeal from the Board of Patent Appeals and Interferences mailed on December 30, 2005. Please amend the above-identified patent application as follows.